

INFORMATION DISCLOSURE CITATION IN AN APPLICATION				Docket Number		Application Number	
				M4065.0082/P082-A		Not Yet Assigned	
				Applicant(s)			
				Paul Farrar			
Filing Date				Group Art Unit			
August 14, 2000				2812			
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	4,532,002	07/1985	WHITE			
	B	4,606,998	08/1986	CLODGO et al.			
	C	5,457,345	10/1995	COOK et al.			
	D	5,667,132	09/1997	CHIROVSKY et al.			
	E	5,691,239	11/1997	HAKEY et al.			
	F	5,762,259	06/1998	HUBACHER et al.			
	G	5,786,270	07/1998	GORRELL et al.			
	H	5,838,069	11/1998	ITAL et al.			
	I	5,866,475	02/1999	YANAGIDA			
FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translations YES NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	J	Soller et al., "A FLEXIBLE MULTI-LAYER RESIST SYSTEM USING LOW TEMPERATURE PLASMA-DEPOSITED SILICON NITRIDE," Journal of the Electrochemical Society, Vol. 131, No. 4, pages 868-72, April 1984.					

EXAMINER	DATE CONSIDERED
R. Pompey	
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	

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EXAMINER	DATE CONSIDERED
R. Pompey	Nitin Parekh
08/18/05	
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